## NOTES:

SUBSTRATE:

Fused Silica

- 2. SURFACE S2 TO BE PARALLEL TO SURFACE S1 TO WITHIN <5 ARCMIN
- 3. COATING (APPLY ACROSS COATING APERTURE):

S1: Nd:YAG Laser R(ABS) >99.5% @ 532nm @ 0° AOI

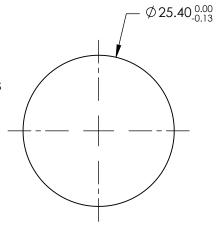
DAMAGE THRESHOLD:

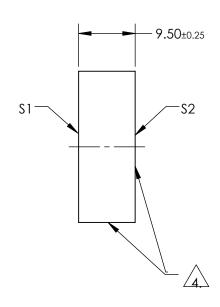
PULSED: 12 J/cm<sup>2</sup> @ 532nm, 10ns, 20Hz

S2: NONE



- 5. SURFACE QUALITY SPECIFICATIONS APPLY ACROSS CLEAR APERTURE
- 6. CLEAR APERTURE AND COATING APERTURE ARE CENTERED ON SURFACES
- 7. ROHS COMPLIANT





## FOR INFORMATION ONLY DO NOT MANUFACTURE PARTS TO THIS DRAWING

SPECIFICATIONS SUBJECT TO CHANGE WITHOUT NOTICE DIMENSIONS ARE FOR REFERENCE ONLY

	\$1	\$2	
SHAPE	PLANO	PLANO	
SURFACE FLATNESS	λ/6	N/A	
SURFACE QUALITY	10-5	COMMERCIAL POLISH	
CLEAR APERTURE	85%	N/A	
BEVEL	PROTECTIVE AS NEEDED	PROTECTIVE AS NEEDED	

			Edmund Optic	S®
THIRD ANGLE _ PROJECTION	$\phi \lhd$	TITLE	25.4mm Dia. 532nm 0° Nd:YAG Laser Mirror	Line
ALL DIMS IN	mm	DWG NO	36327	SHEE 1 OF



SHEET 1 OF 1